Search	

 Application/Control No.	Applicant(s)/Patent under Reexamination
10/786,093	TOYAMA ET AL.
Examiner	Art Unit
Seung H. Lee	2876

SEARCHED			
Class	Subclass	Date	Examiner
235	462.35,46 2.41,462.4 2	3/1/2006	SHL
235	455	3/1/2006	SHL

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
Same as	Above	3/1/2006	SHL

SEARCH NO (INCLUDING SEARC		)
	DATE	EXMR
235/454,472.01(see printouts)	3/1/2006	SHL
PCT cites	3/1/2006	SHL
NPL	3/1/2006	SHL